Electronic Supplementary Information

Composition-tunable 2D SnSe_{2(1-x)}S_{2x} alloys towards efficient

bandgap engineering and high performance (opto)electronics

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Figure S1. Raman spectra of layered SnS2 with various thickness. With the thickness of the samples decreasing, the Eg mode at 210 cm-1 become undetectable.

As shown in **Figure S1**, the peak at 514 cm⁻¹ is a 300nm SiO₂ Raman peak of SiO₂/Si substrate, and the comparison of this SiO₂ Raman peak with 313 cm⁻¹ can qualitatively shows the thickness of SnS₂ samples. With the thickness of the sample decreasing, the E_g mode at 210 cm⁻¹ become undetectable. This can be attributed by the reduction of scattering centers for E_g mode with the thickness decrement of SnS₂ sample, which is in accordance with the previous reports¹⁻³.

Table S1 Compositions and lattice parameter c of $SnSe_{2(1-x)}S_{2x}$ alloys						
x value in SnSe _{2(1-x)} S _{2x} \Box	Atomic % from XPS				XRD	
	Sn3d	Se3d	S	x' =S2p /(Se3d+ S2p)	20 of (001) peak	c-axis d _{spacing} (Å)
1	8.66	18.45	0	1	15.11	5.86
0.75	18.14	10.85	27.99	0.72	14.91	5.94
0.5	14.67	13.59	15.9	0.54	14.64	6.04
0.25	10.32	15.28	4.74	0.24	14.56	6.08
0	20.73	0	42.76	0	14.54	6.09



Figure S2 Sn 3d XPS spectra of bulk SnSe2(1-x)S2x samples.



Figure S3. Naked HRTEM image of figure 3c which clearly shows three different level of brightness that presents different atoms for Sn, Se, and S in the alloy.

Computational methods

All the first-principles calculations in this work are performed by using the projector augmented wave (PAW)^{4, 5} formalism within the frame work of density functional theory (DFT) in the Vienna ab initio Simulation Package (VASP)⁶. The generalized gradient approximation (GGA) of Perdew, Burke and Ernzerhof (PBE) functional⁷ is adopted for electron exchange and correlation. A vacuum layer of no less than 15 Å is used to eliminate the interaction between adjacent images. The cutoff energy for the plane-wave basis set is set to 450 eV. A ($15 \times 15 \times 1$) Monkhorst-Pack *k*-point grid⁸ is used to sample the first Brillouin zone of SnS₂ and SnSe₂ unitcells. Supercells consisting of 4×4 unit cells is constructed to simulate SnS_{2x}Se_{2(1-x)} alloys with different concentrations.

The Brillouin zones of all the $SnS_{2x}Se_{2(1-x)}$ supercells are sampled with a ($5 \times 5 \times 1$) for relaxations. All the structures are fully relaxed with a force tolerance of 0.02 eV/Å.

Figure S4. The lattice constant of $SnSe_{2(1-x)}S_{2x}$ alloy with S concentration that obtained from theoretical model. As seen in Figure S4, the lattice constant value of SnSeS (x=0.5) model is about 0.378nm, which matches very well with the value measured from HRTEM image.

Figure S5. Calculated projected band structure of the different $SnSe_{2(1-x)}S_{2x}$ (a) x = 0.25 and (b) x = 0.75 alloys. The blue and pink dots in the Figures denote the bands dominated by SnS_2 and $SnSe_2$, respectively.

Figure S6. Transfer curves $\binom{I_{sd} - V_g}{g}$ and output curves $\binom{I_{sd} - V_{sd}}{g}$ of SnSe_{2(1-x)}S_{2x} FETs for (a, c) x=0.75 and (b, d) x=0.25.

 $SnSe_{2(1-x)}S_{2x}$ FETs with x=0.25 and 0.75 are fabricated, the output and transfer curves of which are shown in **Figure S4**. The field-effect mobility and 'ON/OFF' ratio of them are all calculated and shown in **Table 2**.

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